

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: CHAKIHARA et al

Serial No.: 10/629,733

Filed: July 30, 2003

For: A Semiconductor Memory Device And A Method

Of Manufacturing The Same, A Method of Manufacturing A Vertical MISFET And A Vertical MISFET, And A Method

Of Manufacturing A Semiconductor Device And

A Semiconductor Device

Art Unit:

Examiner:

## PRELIMINARY AMENDMENT

Mail Stop: Amendment (No Fee) Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

August 20, 2003

Sir:

The following amendments are respectfully requested in connection with the above-identified application as listed below and as set forth on the following pages:

Amendments to the Specification and Abstract

Remarks are included following the amendments